

Form PTO-1449

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IN AN APPLICATION

(Use several sheets if necessary)

Document Number (Optional)

TSMC-01-116/786

Application Number

10/042,573

Applicant

Kei-Wei Chen et al.

Filing Date

01/09/02

Group Art Unit

2823
1746

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
ME	5704987	11/6/98	Haynh et al.	134	6	1/19/96
ME	6194366	2/27/01	Naghshineh et al.	510	175	11/16/99
ME	6152148	11/28/00	George et al.	134	2	9/3/98
ME	6099662	8/8/00	Wang et al.	134	26	2/11/99
ME	5981454	11/9/99	Small	510	175	2/14/97
ME	6044851	4/4/00	Grieger et al.	134	1.3	6/15/98
ME	6235145	5/22/01	Li et al.	156	345	7/20/98
ME	6046112	4/4/00	Wang	438	693	12/14/98
ME	6114241	9/5/00	Choi et al.	438	677	6/23/99
ME	5679169	10/21/97	Gonzales et al.	134	1.3	12/19/95

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portion of Pages, Etc.)

EXAMINER

Michelle Estrada

DATE CONSIDERED

4/24/03

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